



Norman Ruhnke (Autor)

A deep ultraviolet laser light source by frequency doubling of GaN based external cavity diode laser radiation



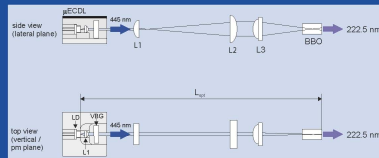
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Forschungsberichte aus dem

Ferdinand-Braun-Institut,
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für Höchstfrequenztechnik

Innovationen mit Mikrowellen & Licht

A deep ultraviolet laser light source
by frequency doubling of GaN based
external cavity diode laser radiation



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